OIPE IAP40
JAN 30 2006
PATENT & TRADEMARK OFFICE



IN THE UNITED STATES PATENT AND TRADEMARK OFFICE

| | | |
|---|---|---|
| In re Patent Application of: | ) | |
| Kenshi KANEGAE et al. | ) | Group Art Unit: 1765 |
| Serial No. 10/679,464 | ) | Examiner: Kin-Chan Chen |
| Filed: 10/7/2003 | ) | Confirmation No. 5297 |
| For: ETCHING METHOD, SEMICONDUCTOR AND FABRICATING METHOD FOR THE SAME | ) ) ) ) | Date: January 30, 2006 |

CERTIFICATE OF MAILING OR TRANSMISSION
[37 CFR 1.8(a)]

I hereby certify that this correspondence is being deposited with the United States Postal Service with sufficient postage for First Class Mail in an envelope addressed to: Mail Stop _____, Commissioner for Patents, P.O. Box 1450, Alexandria, Virginia 22313-1450, or being facsimile transmitted to the USPTO at 571 273 8300 , on January 30, 2006.

Signature: _____

Name: Jeannie Saxton

**AMENDMENT AFTER FINAL REJECTION**

Mail Stop **AF**
Commissioner for Patents
P.O. Box 1450
Alexandria, VA 22313-1450

Sir:

In response to the Office Action dated October 31, 2005, and in connection with the concurrent filing of Applicants' Request for Continued Examination, it is respectfully requested that the following amendments be fully considered by the Examiner.